

ATAMI Standard Operating Procedure

Filmetrics F20EX

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Revision	Date	Description/Change	Curator
0	12/19/2019	New document	Randy Greb

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Scope:

Collection of Thin Film thicknesses with the Filmetrics F20EX at Atami.

Introduction to recipe setup for the system.

System Specifications:

See Description on Atami website.

Safety:

General

Normal room protocol.

PPE Required

Normal room PPE.

Hazardous Energies

Electrical

NA

Mechanical

NA

Stored/Potential

NA

Thermal

NA

Materials/Consumables Hazards

NA

Interlocks

NA

Training Requirements:

- 1. Pass all ATAMI required safety courses
- 2. Finish lab tour with qualified ATAMI trainer.
- 3. Complete all hands on training for this system and signed off by trainer.
- 4. Verify access to this document for reference.

Standby Condition:

- 1 Close software
- 2 Turn light source off.
- 3 Turn analyzer power off.
- 4 Put computer to sleep.
- 5 Log out of card reader.

Procedures:

How to turn on the system and do a basic measurement:

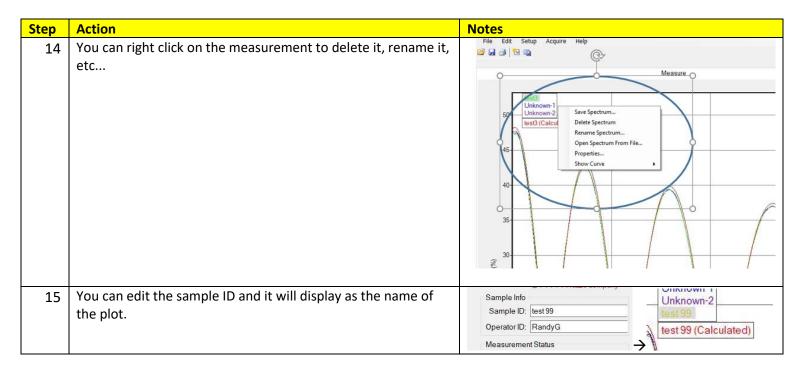
Step	Action	Notes
1	If power is off, the switch is at the back right of the system. Turn it on.	
2	Then press the green light source button to turn on the light source.	FILMETRICS Hight source
3	Then open the software with the FILMeasure icon.	FluMeasure
4	Let the lamp warm up for 20 minutes if you want accurate measurements. You can proceed if you just want a quick measurement.	
5	If you have a known recipe, select it from the dropdown. Otherwise, you'll have to create your own recipe per the procedure below.	Baseline Analyze SiO2 16kA on Si Edit Recipe

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Step	Action	Notes	
6	Place your sample under the light source and press the "Baseline" button. Then follow the prompts. The steps are also outlined here.	Measure Baseline Analyze	
7	Press "Take Sample Reflectance".	The system will measure reflectance from your sample.	
8	Remove your sample and place one of the reflection samples on the stage.	ATAMI has two standards (Si for bright, BK7 for darker surfaces). You can use either one of these, or use your own, if it matches one of the choices in the reflectance standard drop-down list.	
9	Press "Take Reflectance Standard"	The system will measure reflectance from the reflectance sample.	
10	Remove the Reflectance standard so that there is nothing on the stage.		
11	Press "Take Background".	The system will measure background noise to be subtracted from the measurement.	
12	After background light level is collected, press "Finish".		
13	Put your sample back on the stage and press "Measure".	The Filmetrics will then collect the spectrum (reflectance % by wavelength) and display it on the screen. It will also show the value for film thickness, the goodness of fit to the thickness model, and the calculated spectrum for the recipe your used. Repeat measurements will be added to the screen.	

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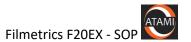




How to collect n and k values:

Step	Action	Notes
1	Choose your starting recipe and then press the "Edit Recipe" button.	
2	Open up all the recipe options by pressing the little plus boxes.	Units: Nanometers (nm) Composition Layer Medium Air Ain Substrate Si V V Substrate Si V V V V V V V V V V V V V
3	At this point you can select the check boxes under measure to get information in addition to thickness.	The robust measurement option in the Analysis Options tab will only work for thickness measurements. Any other measurements will

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Step	Action	Notes
		switch it to the setup as shown. Analysis Method FFT (thickness only) Robust (adaptive; thickness only) FEXACT Compensate for: Unmodeled backside reflections Tilted sample/Lost light Lock together layers with identical: Thickness Composition The advance button will allow some changes in the calculations and wavelength used for displaying n and k. The default is 632.79 nm. Advanced Analysis Options Convergence Criteria GOF greater than: GOF greater than: User-specified solver cycles Maximum solver cycles: Display Details Wavelength for n and k display: OK Cancel
4	After you change this setup, you can press OK, then Measure again, and the new information will be available.	Measurement Results SiO2 = 16382 Å n(632.8 nm)=1.4567 k(632.8 nm)=0.0000 Goodness of fit = 0.99735

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How to create a new recipe:

Step	Action	Notes
1	Press the "Edit Recipe" button.	rg SiO2 2um on Si Edit Recipe
2	Select an existing recipe to edit, or press the "Create New Recipe" icon.	If you create a new recipe, the default recipe will be loaded as a starting point from there.
3	Build your film stack in the "Film Stack" tab.	For best result try to get the film stack and associated thickness in the recipe to match as closely to the actual materials as possible. This is also where you tell the recipe what to measure. The tabs ("Analysis Options", "Alarms", "Acquisition Settings") can be modified for your particular recipe. Refer to the user manual for more details on these options.
4	You can save the recipe to a different name.	You cannot modify the default recipe.
	After re-naming, you can also then save it to a different file location as a backup.	

How to import n and k values in to a new custom material file:

Step	Action	Notes
1	After measuring n and k from your sample, select "File-> Save measured n & k", and save the file to your ATAMI user directory.	This will save the table of n and k values by wavelength.
2	Select "Edit -> Material Library"	

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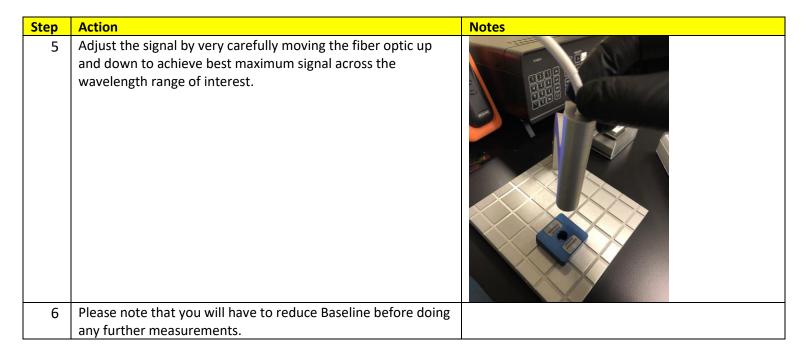
Step	Action	Notes		
3	Press "Open" and then import the values from the file you just saved (extension will be .fitnk).	The Table will then fill in with the saved values and Selected values will be saved.		
4	The model will then be custom. There are three algorithms that you can choose from and fine tune.	Table Craph Selected Values File Information Natural N		
5	Set the material type, and then Choose "Save As" to save it. For custom, local materials, always save the Material Type as "other" with the naming convention listed here.	The standard material types are reserved for the standard material files from Filmetrics.		
6	Always save it with this naming convention - atami_initials_filmtype_thickness.fitnk See example to the right. This ensures quick, safe material file management. You can also save backups in your user directory.	New folder		

How to adjust illumination:

This should only be done if you are having issues getting good data from your sample.

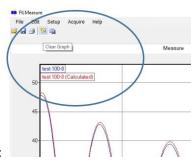
Step	Action	Notes
1	Select the recipe you will be using.	
2	Place the reflectance standard used with your recipe on the	
	the stage (Si or BK7).	
3	Select "Setup -> Raw Signal"	The raw signal will then be displayed.
4	If any region of the spectrum saturates (4000 counts or higher), you may need to adjust integration times.	FILMETICS The state of the sta
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Misc How To:

Clear all the graphs in the display:



Press the Clear graph icon:

Save measurement data to a CSV file, delete measurements from history, etc::

Go to the History tab and use save All Measurement Functions:.

Measurements		
Save As	Delete All	Сору
Delete Selected	Send	d Selected To Measure

Standard or Example Recipes:

Default:

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This is the default recipe used when creating a new recipe. It uses SiO2 on Si.

Basic Troubleshooting:

If you:

Step	If	Then	Notes
1	Have a poor goodness of fit on the same sample after getting good results:	Be sure to do the Baseline before all measurements.	Illumination may have changed.
2	Have a poor goodness of fit on a new sample.	 Check your recipe setup, relative to the sample. Be sure to do the baseline setup. Illumination may have dropped. Check for maximum illumination per the procedure above. 	

Any other issues:

Step	If	Then	Notes
1	Miscellaneous Software and Hardware	Contact ATAMI staff.	
	issues.		

Attachments:

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